

U.S. Department of Commerce, Patent and Trademark Office				Atty Docket No.		Serial No.	
				M-12332 US		Unknown	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Applicants			
(Use several sheets if necessary)				Pablo I. Rovira and Lars Markwort			
				Filing Date		Group	
				Herewith		Unknown	
U.S. Patent Documents							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,392,116	Feb. 21, 1995	Makosch	356	351	
	AB	5,502,567	Mar. 26, 1996	Pokrowsky et al.	356	367	
	AC	5,889,593	Mar. 30, 1999	Bareket	356	445	
	AD	6,002,477	Dec. 14, 1999	Hammer	356	307	
	AE	6,160,621	Dec. 12, 2000	Perry et al.	356	381	
	AF	6,122,052	Sep. 19, 2000	Barnes et al.	356	328	
	AG	6,275,291	Aug. 14, 2001	Abraham et al.	356	367	
	AH						
Foreign Patent Documents							
							Translation
		Document	Date	Country	Class	Subclass	Yes No
	AI	EP 0 987 537 A2	Mar. 22, 2000	Europe			X
	AJ						
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AK	Azzram, R., "An arrangement of two reflective photodetectors for measuring all four Stokes parameters of light", <i>American Institute of Physics</i> (1991) Pages 2080-2082.					
	AL	Bennett, J., "Polarizers" <i>Optical Elements</i> , Chapter 3, Pages 3.1-3.70.					
	AM	Cumming, D. et al., "A variable polarisation compensator using artificial dielectrics" Elsevier Science (1999) Pages 164-168.					
	AN	Hauge, P., "Recent Developments In Instrumentation In Ellipsometry", <i>Surface Science</i> 96 (1980) Pages 108-140.					
	AO	Horn, T., "Liquid Crystal Imaging Stokes Polarimeter", <i>Astronomical Society of the Pacific</i> (1999) Pages 33-37.					
	AP	Jasperson, S., "A Modulated Ellipsometer For Studying Thin Film Optical Properties And Surface Dynamics" <i>Surface Science</i> 37 (1973) Pages 548-558.					
Examiner			Date Considered				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.							

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	AI								
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)									
	AK	Kazama, A. et al., "Compact and high-speed ellipsometer" <i>SPIE</i> Vol. 1681 Pages (1992) 183-188.							
	AL	Lee, J. et al., "Rotating-compensator multichannel ellipsometry: Applications for real time Stokes vector spectroscopy of thin film growth", <i>Review of Scientific Instruments</i> 69 (1998) Pages 1800-1810.							
	AM	Oliva, E., "Wedged double Wollaston, a device for single shot polarimetric measurements", <i>Astronomy & Astrophysics Supplement Series</i> 123 (1977) Pages 589-592.							
	AN	Smajkiewicz, A., "An Argument for a Filter Array vs. Linear Variable Filter in Precision Analytical Instrument Applications".							
	AO	"Stokes Polarimetry Using Liquid-Crystal Variable Retarders", downloaded 6/11/01 from < http://www.meadowlark.com/AppNotes/appnote3.htm >, Meadowlark Optics, Inc. (1998-2001).							
	AP	Chapter 3, Ellipsometer Systems, "Theory and Analysis of Measurements in Ellipsometer Systems" Pages 167-268.							
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